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FAX

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Date January 15, 2004

To Examiner Erin M. Gill

Of USPTO Group Art Unit 2881

Fax 703-872-9306  
703-746-9311

From Alan J. Kasper

Subject Previously Submitted Amendment

Our Ref Q59993 Your Ref 09/606,679

Pages 25 24  
(including cover sheet)

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Please call attention to problems with this transmission by return fax or telephone. Thank you.

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Dear Examiner Gill,

Per your request, attached is a copy of an amendment that was filed on August 7, 2003 together with a copy of the check for \$110.00 and the mail room stamped receipt dated August 7, 2003, listing both the payment and the amendment. Please advise if you need anything more.

Regards, Alan Kasper (Reg. 25,426)

5/6

**FILING RECEIPT**  
**PLEASE DATE STAMP AND RETURN TO US - BOX 235X**

In re application of

Isao AMEMIYA

Appln. No.: 09/606,679

Confirmation No.: 8440

Filed: June 30, 2000



Group Art Unit: 2881

Examiner: Erin M. Gill

For: ELECTRON BEAM DRAWING MASK BLANK, ELECTRON BEAM DRAWING MASK, AND  
METHOD OF MANUFACTURING THE SAME

PAPER(S) FILED ENTITLED:

1. Amendment Under 37 C.F.R. §1.111
2. Petition for Extension of Time (in duplicate with Check No. 228025  
in the amount of \$110.00).

SUGHRUE MION, PLLC  
Telephone: (202) 293-7060  
Facsimile: (202) 293-7860

DOCKET NO.: Q59993  
ATTORNEY/SEC: AJK/prc  
Date Filed: August 7, 2003

WASHINGTON OFFICE

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SUGHRUE MION

JAN 15 2004

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**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q59993

Isao AMEMIYA

Appln. No.: 09/606,679

Group Art Unit: 2881

Confirmation No.: 8440

Examiner: Erin M. Gill

Filed: June 30, 2000

For: ELECTRON BEAM DRAWING MASK BLANK, ELECTRON BEAM DRAWING  
MASK, AND METHOD OF MANUFACTURING THE SAME

**AMENDMENT UNDER 37 C.F.R. § 1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**FILED**

AUG - 7 2003

Sir:

In response to the Office Action dated April 10, 2003, please amend the above-identified application as follows on the accompanying pages.